

From Plasma to Mass Spectrum:
A Novel Ion Guide Coupled to HR-TOF-MS
Benchmarked Against
Conventional Plasma Diagnostics

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sanna.benter@uni-wuppertal.de

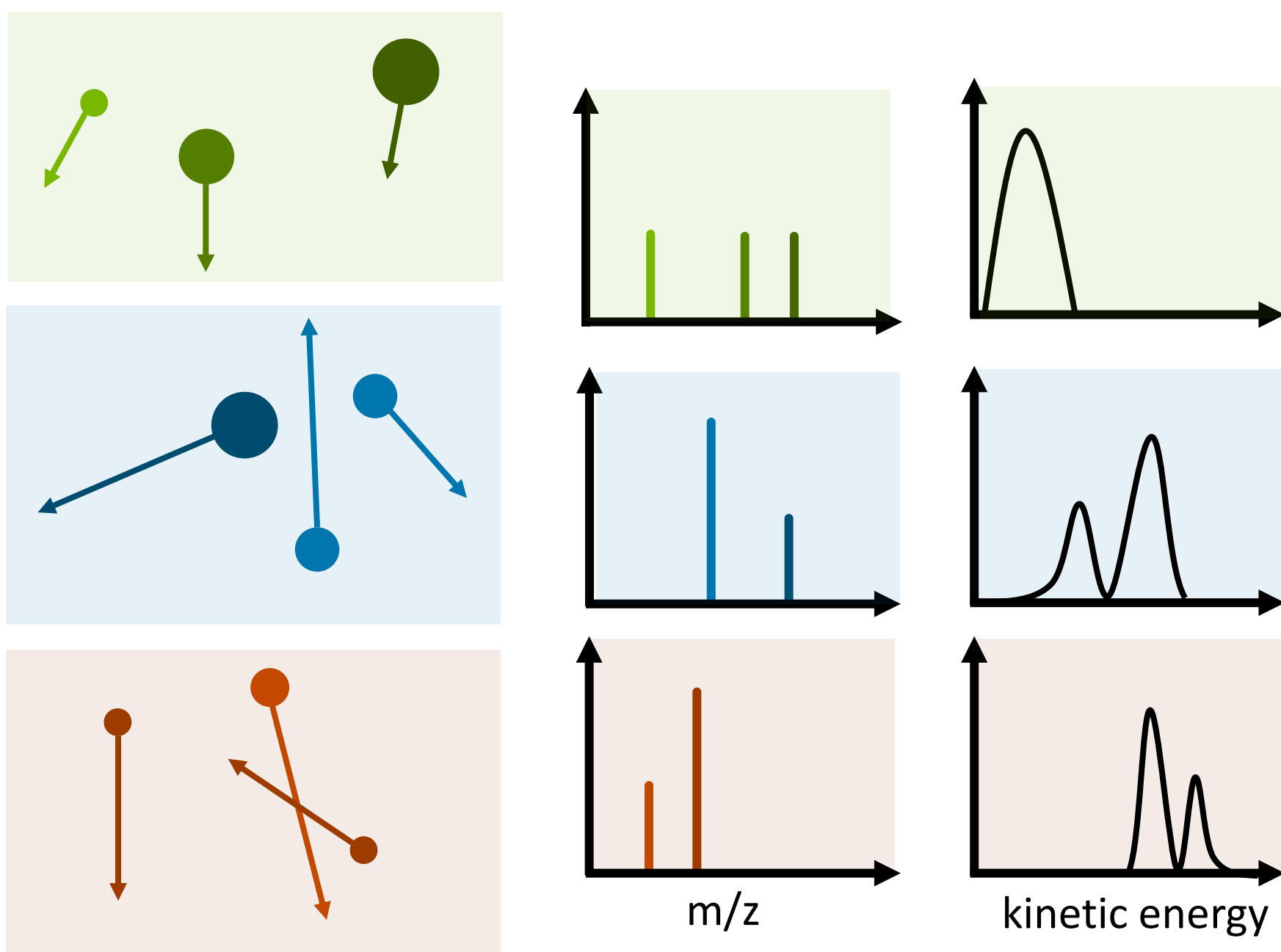
Sanna Benter, Niklas Pengemann, Hendrik Kersten, Thorsten Benter

Motivation

Plasmas are found in numerous industrial systems, serving either as an integral part of the process or as an unintended by-product. They inevitably generate ions that interact with surrounding surfaces.

The impact these ions have on surfaces depends not only on their **chemical identity** but also by their **kinetic energy and spatial distribution**.

Plasma region

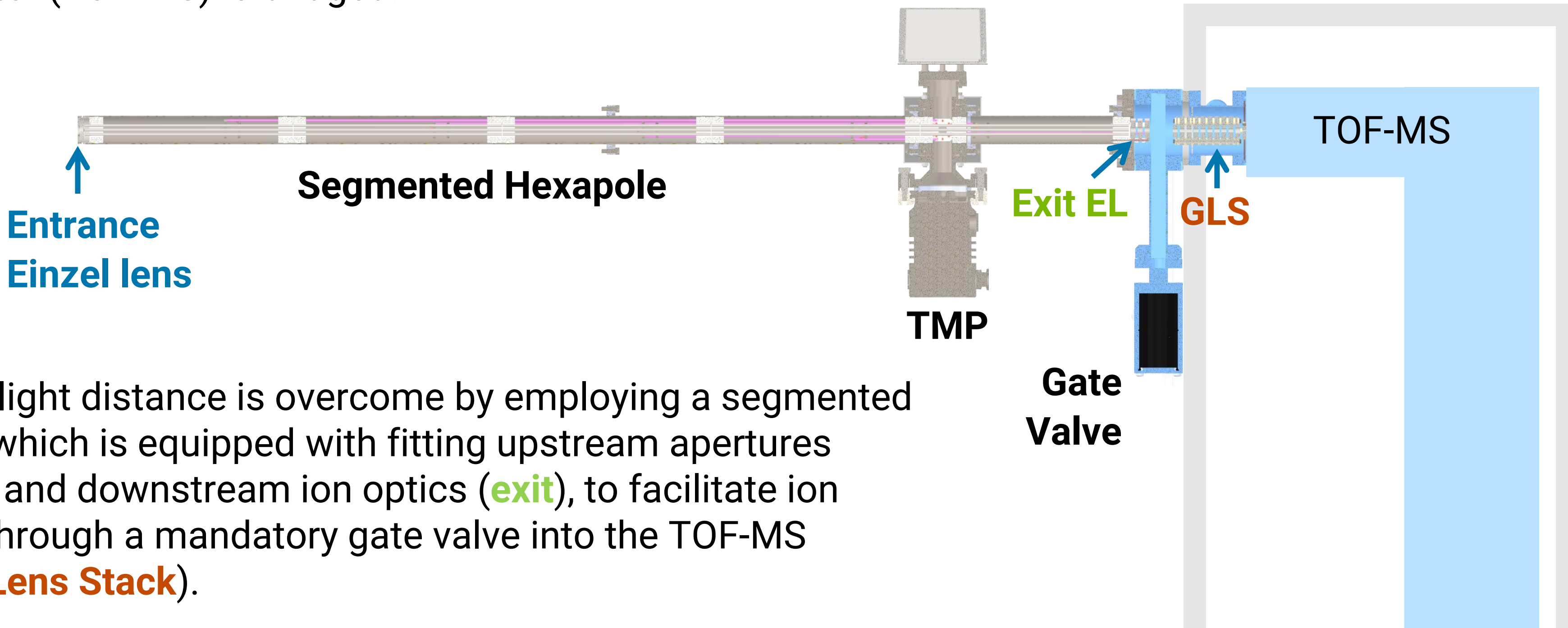


Goal

Develop a mass spectrometric approach that allows the analysis of ionic mass and kinetic energy in different locations.

Novel Ion Guide Coupled to HR-TOF-MS

In this work, a **distance of 170 cm** between a plasma chamber and a high-resolution time-of-flight mass spectrometer (TOF-MS) is bridged.

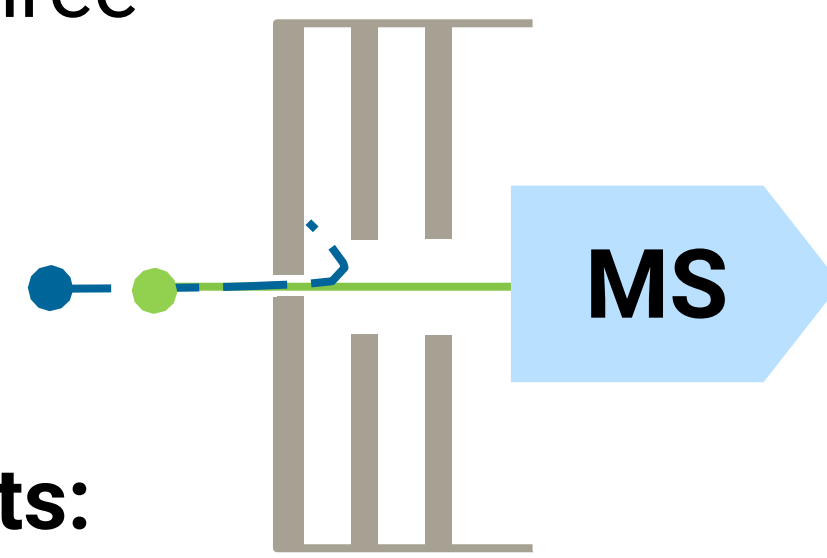


The main flight distance is overcome by employing a segmented **hexapole**, which is equipped with fitting upstream apertures (**entrance**) and downstream ion optics (**exit**), to facilitate ion transport through a mandatory gate valve into the TOF-MS (**Gradient Lens Stack**).

Kinetic Energy Measurement

Entrance consist of an **Einzel lens** with three electrodes to

1. **focus and guide** ions
2. **restrict gas flow** to reduce pressure inside the hexapole and
3. Allow for **kinetic energy measurements**:



The inner electrode potential is gradually increased. As **ions with insufficient kinetic energy** are successively blocked, the decrease in count rate (cps) reflects the **ion kinetic energy distribution**.

Spatial Resolution

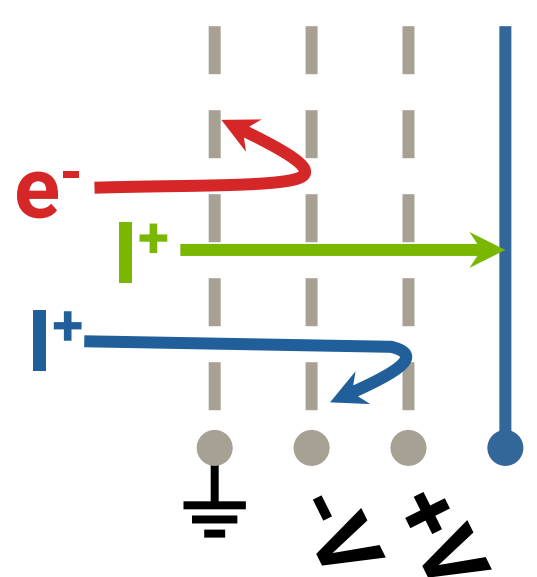
Spatial resolution is achieved by mounting the entire transfer stage and TOF-MS on a linear manipulator (Vab Vakuum-Anlagenbau GmbH, Elmshorn, Germany),

The hexapole ion guide and inlet were manufactured by Fasmatech (Athens, Greece).

Commercial Approaches and their Operational Principles

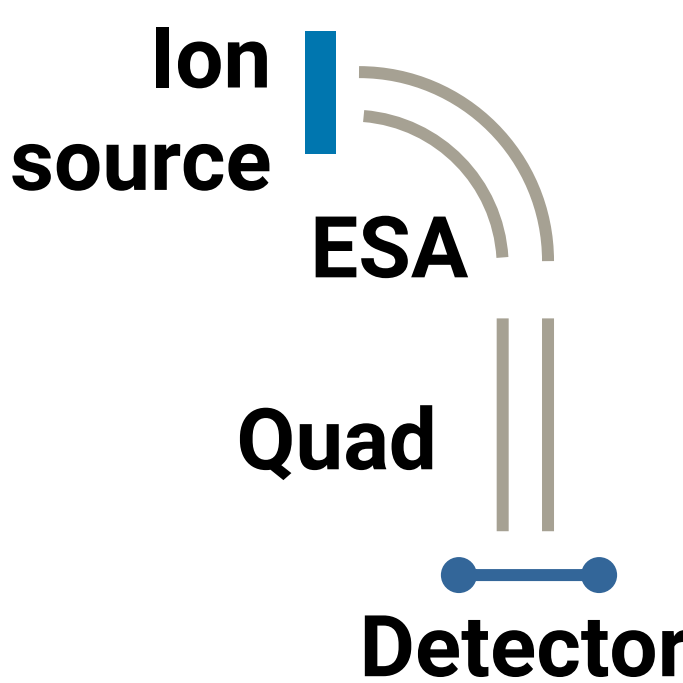
RFEA

Uses the same retarding-field principle with a grid-based design and a detector positioned behind the final electrode.



EQP

Measures ion mass-to-charge ratios and energy distributions using a quadrupole mass filter and electrostatic energy analyzer.



Langmuir Probe

Operates by varying a probe bias relative to the plasma and measuring the resulting current-voltage (I-V) characteristic.

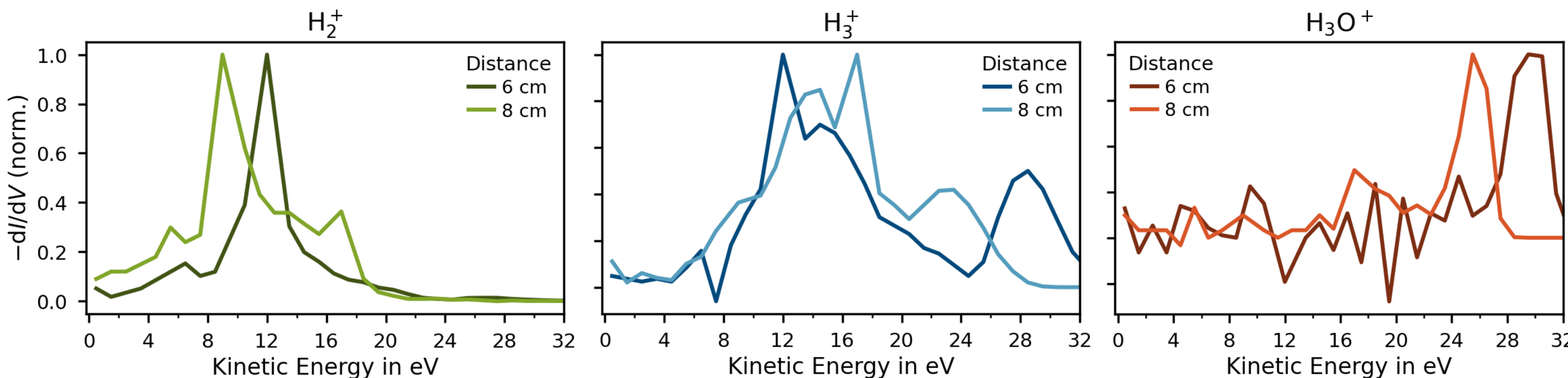
OES

Identifies excited species and monitors plasma composition by analyzing the emitted light spectrum.

Exemplary Results and Comparison

Exemplary Results

Measurements of a radio-frequency (RF) hydrogen plasma reveal **distinct ion energy** populations. The measured kinetic energies depend systematically on both the **ion species** and the **distance** from the RF electrode.



Key Advantages

1. **High sensitivity and high-resolution**
Clear identification of very weak ion signals
Unique among the compared diagnostic methods
2. **Robust against high electron current densities**
Additional flight path rejects unwanted ion currents
Not achievable with RFEA or Langmuir probes
3. **Continuously adjustable spatial resolution**
4. **Very low kinetic energy uncertainty (< 0.1 eV)**
Through einzel lens design rather than grid structure

Limitations

1. **Requires sufficiently separated ion kinetic energies for temporal resolution**
Single-lens energy analyzer can be operated in RFEA mode for high temporal resolution
2. **Currently only tested for kinetic energies up to 120 eV**
Higher kinetic energies measurable, but uncertainty rises to > 2 eV

Mass-to-charge
Kinetic Energy
Spatial resolution
Non-invasive

	OES	RFEA	EQP	Langmuir	Our Method
Emission-limited					
Plasma-dependent					
Sight integrated					